

Application/Control No.	Applicant(s)/Patent under Reexamination
10/656,452	ELLSBERRY ET AL.
Examiner	Art Unit
Chris C. Chu	2815

	SEARCHED				
Class	Subclass	Date	Examiner		
257	E27.161, E27.144, E27.137& 738	10/17/2006	C.C.		
257	E25.006	10/17/2006	C.C.		
257	E25.013	10/17/2006	C.C.		
257	E21.511	10/17/2006	C.C.		
257	723 & 737	10/17/2006	C.C.		
257	686 & 777	10/17/2006	C.C.		
257 `	778 & 786	10/17/2006	C.C.		
257	780 & 781	10/17/2006	C.C.		
257	712 & 713	10/17/2006	C.C.		
257	747 & 692	10/17/2006	C.C.		
257	693 & 698	10/17/2006	C.C.		
361	783 & 803	10/17/2006	C.C.		
361	760	10/17/2006	C.C.		
438	108 & 109	10/17/2006	C.C.		

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
As same	as above	10/17/2006	c.c.	
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
Searched in US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; FPRS; and IBM_TDB;	10/17/2006	C.C.		
Consulted with Clark, Sheila 257/686, 777, 778, 786, 780 & 781	4/6/2005	C.C.		
Consulted with Jackson, Jerome 257/712, 713 & 747	4/6/2005	C.C.		
Consulted with Graybill, David 257/686, 692, 698, 723, 737, 738, 778, 786, E25.006, E25.013, E21.511 & E23.069	4/6/2005	C.C.		